



1763

3790 USA/DISPLAY/AKT/BG  
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
Kurita, et al.  
Serial No.: 09/464,362  
Filed: December 15, 1999  
For: DUAL SUBSTRATE LOADLOCK  
PROCESS EQUIPMENT

Examiner: MacArthur, S.

Art Unit: 1763

#1012

Assistant Commissioner for Patents  
Washington, D.C. 20231

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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Dear Sirs:

In accordance with 37 CFR 1.56, 1.97, and 1.98, enclosed please find Form PTO-1449 listing the attached references which might be deemed material to the examination of the above-identified application. The information disclosure statement submitted herewith is being filed before the mailing date of a first Office Action after filing of a Request for Continued Examination under 1.114. It is believed that no fee is due. Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-0585. A duplicate of this letter is enclosed.

Respectfully submitted,

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June 10, 2002  
Date

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